



NIT-215

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

S. KONDO et al

Serial No. 09/637,570                      Group Art Unit: 2812

Filed: August 14, 2000 Examiner: Ha Nguyen

For: POLISHING METHOD, METALLIZATION FABRICATION  
METHOD, METHOD FOR MANUFACTURING  
SEMICONDUCTOR DEVICE AND SEMICONDUCTOR  
DEVICE

AMENDMENT

Commissioner for Patents  
Alexandria, VA 22313

Sir:

In response to the Office Action mailed October 29,  
2003, please amend the above-identified application as  
follows.